

## Optically pumped nanolaser based on two magnetic plasmon resonance modes

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We propose and analyze theoretically a double magnetic plasmon resonance nanolaser, in which ytterbium-erbium codoped material is used as the gain medium. Through design of the double magnetic resonance modes, pumping light (980 nm) can be resonantly absorbed and laser light (1550 nm) can be resonantly generated simultaneously. We introduce a set of rate equations combined to describe the operation of the laser and predict the lasing condition. According to our calculations, the disadvantage that pumping light is difficult to be absorbed by a thin slab of gain materials can be overcome. © 2009 American Institute of Physics. [DOI: 10.1063/1.3095437]

Reducing mode volume in cavities is very favorable for achieving strong light-matter interaction processes.<sup>1</sup> These strong interactions are of great benefit to applications in light emitting devices. Recently, in order to further miniaturize mode volume and physical size of the structure, researchers turn to use metal instead of dielectric to bound the mode field.<sup>2-6</sup> For example, a metallic-coated cavity formed by encapsulating a semiconductor heterostructure in a thin gold film is used to obtain mode volume far smaller than conventional dielectric cavities.<sup>2</sup> In addition, due to the strong localized surface plasmon effect, electromagnetic energy is also able to be highly confined in nanoscale.<sup>3-6</sup>

In 1999, Yen *et al.*<sup>7</sup> proposed the split-ring resonator to realize magnetic plasmon resonance in microwaves. Since then, scientists introduce many new structures to achieve magnetic resonance in high frequency region, such as fish net<sup>8</sup> and nanosandwich.<sup>9</sup> It is shown that such magnetic response structures offer a great promise for applications in negative refractions,<sup>10-12</sup> perfect lens,<sup>13</sup> subwavelength waveguides,<sup>14</sup> etc. Very recently, magnetic plasmon resonance is proposed as an efficient way to produce nanolasers.<sup>15,16</sup> However, to the best of our knowledge, all the structures up to now only resonate with the lasing light. In these structures, most of external energy is difficult to be absorbed by these nanocavities.

In this work, we design a metallic nanosandwich cavity, which can possess two magnetic plasmon resonance modes at two prescribed resonance wavelengths. Combined with the ytterbium-erbium codoped gain material Er:Yb:YCOB, this cavity can have resonance not only at lasing wavelength but also at pumping wavelength, which lead to efficient pump-laser conversion.

Figure 1(a) presents the proposed laser arrays constructed by immersing a regular array of rectangular silver slab in gain medium Er:Yb:YCOB, which is supported by a silver film and SiO<sub>2</sub> glass substrate. The geometry parameters of the structure shown in Figs. 1(b) and 1(c) are defined

as follows: the immersed upper silver slab is a rectangular slab with a size of 310×245×50 nm<sup>3</sup>. The gap size between the immersed silver slab and bottom silver film is 50 nm. The thicknesses of the silver film, gain medium layer above the silver film, and SiO<sub>2</sub> glass substrate are 50, 250, and 250 nm, respectively. The permittivity of the silver is given by  $\epsilon(\omega) = \epsilon_\infty - \omega_p^2 / (\omega^2 + i\omega/\tau)$ . The values of  $\epsilon_\infty$ ,  $\omega_p$ , and  $\tau$  fitted to experimental data in the 950–1800 nm wavelength range are 1.0,  $1.38 \times 10^{16}$  rad/s, and 33 fs, respectively. The refractive indices of Er:Yb:YCOB and SiO<sub>2</sub> substrates are measured to be 1.3 and 1.5, respectively.

In this paper, we focus on the lasing condition of a single magnetic resonator. The distance between the nearest-neighbor resonators is large enough (~1000 nm) and the coupling interaction among these resonators can be neglected. From Pendry's theory, the structure shown in Fig. 1(b) can be seen as an equivalent inductance-capacitance circuit. When magnetic resonance occurs, the electromagnetic energy is mainly stored in the space between the silver slab and film, so the structure can be considered as a cavity of confining light. One main character of magnetic resonance

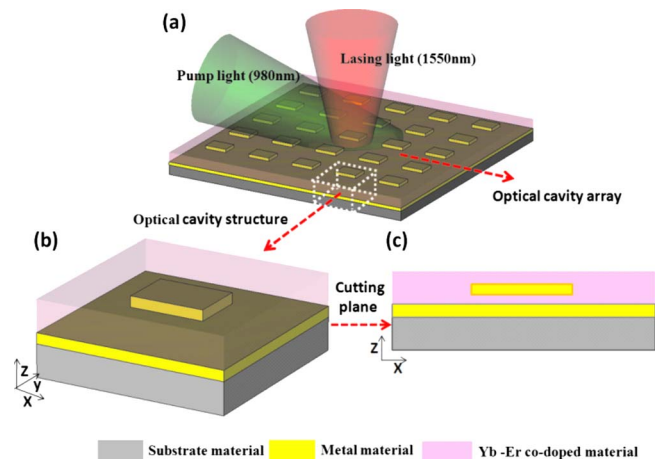


FIG. 1. (Color online) Metallic magnetic resonance nanolaser structures. (a) Laser arrays. (b) Single laser cell structure. (c) Cutting plane ( $z$ - $x$  plane) of single laser cell structure.

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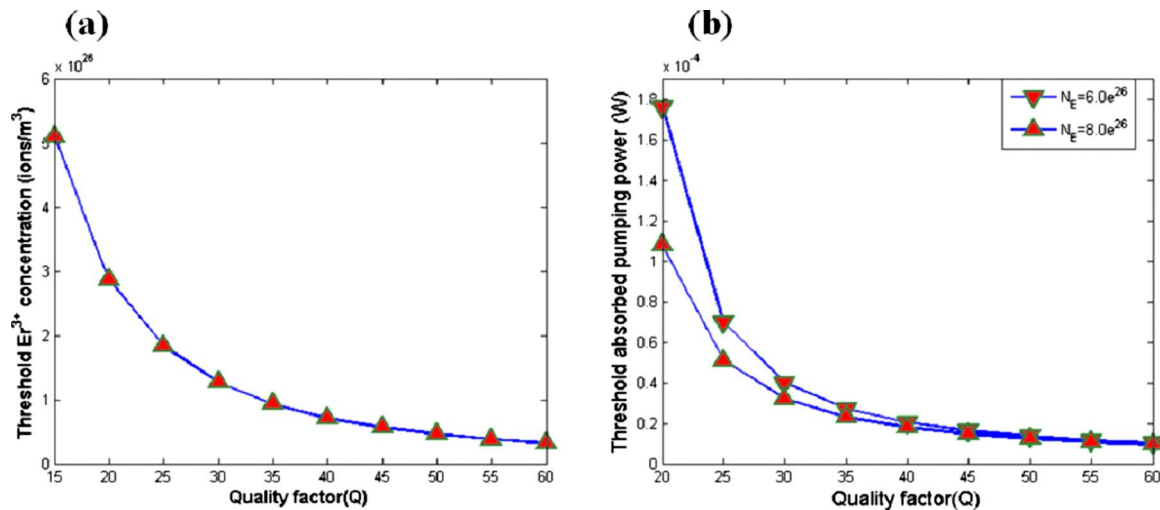


FIG. 4. (Color online) Threshold lasing condition. (a) Threshold  $\text{Er}^{3+}$  concentration plotted as a function of modified quality factor  $Q$ . (b) Absorbed threshold pumping power plotted as a function of modified quality factor  $Q$  at two different erbium concentrations.

rate of exponential decay of the electromagnetic energy for the given resonance mode), group velocity, effective mode volume, and normalized spatial intensity distributions, are calculated in our simulations and listed in Table I. The other material parameters used in the calculation are also included in Table I. In general, the  $\text{Yb}^{3+}$  concentration is an order of magnitude higher than  $\text{Er}^{3+}$  concentration. In our calculations, we fix the  $\text{Yb}^{3+}$  concentration at  $5.0 \times 10^{27}$  ions/m<sup>3</sup> and predict the threshold  $\text{Er}^{3+}$  concentrations. Substituting the pumping mode and lasing mode parameters into Eqs. (1)–(5), and assuming the total photon number of lasing mode in the cavity to be 1 and the pumping rate to be high enough, we can predict the  $\text{Er}^{3+}$  threshold doping concentrations to be  $4.6 \times 10^{25}$  ions/m<sup>3</sup>. In our theoretical work, we consider the film influence on the property of metal material by reducing the quality factor of lasing mode, which corresponds to larger metallic losses in metallic film. Figure 4(a) shows the threshold doping concentration plotted as a function of modified quality factor  $Q$  of lasing mode. It can be seen from the figure, as the quality factor decreases, the threshold doping concentration increases. When  $Q$  is decreased from 50 to 15, the corresponding threshold  $\text{Er}^{3+}$  concentration is increased from  $4.6 \times 10^{25}$  to  $5.1 \times 10^{26}$  ions/m<sup>3</sup>. Typical  $\text{Er}^{3+}$  concentration in Er:Yb:YCOB is in the range of  $10^{25}$ – $10^{27}$  ion/m<sup>3</sup>. So, Er:Yb:YCOB can theoretically satisfy the operating condition of the metallic magnetic resonance nanolaser. Choosing  $\text{Er}^{3+}$  concentration at  $6.0 \times 10^{26}$  and  $8.0 \times 10^{26}$  ions/m<sup>3</sup>, we calculate the corresponding absorbed threshold pumping power ( $\hbar\omega_p\sigma_Y v_p F_p N_p N_Y / \eta_p$ ,  $\eta_p$  is the quantum efficiency and approximately equal to 1), respectively, as shown in Fig. 4(b). From Fig. 4(b), at a fixed  $\text{Er}^{3+}$  concentration, the absorbed threshold pumping power increases with the decrease in  $Q$  factor. This means that more metallic losses must be compensated by higher pumping power.

In summary, a metallic double magnetic plasmon resonance nanolaser has been proposed. Due to that both the pumping mode and the lasing mode are resonant in the cavity, the pumping efficiency can be enhanced greatly. The finite-difference time-domain (FDTD) method and a set of

rate equations are introduced to model the operation of the laser and predict the lasing condition. Results prove that the proposed double resonance laser can work as a compact nanolaser with quite low threshold value.

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